

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Takeshi FUKADA, et al)
Serial No. 09/904,906) Group Art Unit: 2825
Filed: 07/16/01) Examiner: L. Malsawma
For: GLASS SUBSTRATE ASSEMBLY,)
SEMICONDUCTOR DEVICE AND METHOD)
OF HEAT-TREATING GLASS SUBSTRATE)

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**SECOND REQUEST FOR ACKNOWLEDGMENT OF
INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents
P. O. Box 1450
Alexandria VA 22313-1450

Sir:

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I hereby certify that this correspondence is being deposited with
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Harvey L. Davis

Applicants acknowledge with appreciation the Notice of Allowability and Issue Fee Due form mailed June 17, 2004 acknowledging the Information Disclosure Statement filed March 31, 2004.

The Notice of Allowability did not, however, include an initialed Form PTO-1449 acknowledging the Information Disclosure Statement filed December 9, 2003. Therefore, it is respectfully requested that the Examiner evidence consideration of the references cited in the IDS of December 9, 2003 by providing a copy of the initialed Form PTO-1449.

If a conference would be beneficial in expediting the prosecution of the instant application, the Examiner is invited to telephone the undersigned to arrange such a conference.

Respectfully submitted,

[Signature]

Eric J. Robinson
Registration No. 38,285

ROBINSON INTELLECTUAL PROPERTY LAW OFFICE, P.C.
PMB 955
21010 Southbank Street
Potomac Falls, Virginia 20165
(571) 434-6789
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This will acknowledge receipt of the following:

1. Information Disclosure Statement
2. PTO 1449 Form w/ copies of references listed thereon
3. Check No. 2650 in the amount of \$180.00 (ids)
4. Certificates of Mailing for each of the above

In re PATENT application of:

TAKESHI FUKADA et al

Serial No. 09/904,906

Filed: 07/16/2001

Due Date: 12/12/2003

For: GLASS SUBSTRATE ASSEMBLY, SEMICONDUCTOR DEVICE AND METHOD OF HEAT-TREATING GLASS SUBSTRATE

Docket: 0756-2332

December 9, 2003

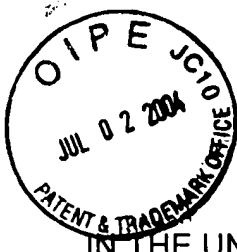
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Attorney Docket No. 0756-2332

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Takeshi FUKADA et al.

Serial No. 09/904,906

Filed: July 16, 2001

For: GLASS SUBSTRATE ASSEMBLY,
SEMICONDUCTOR DEVICE AND
METHOD OF HEAT-TREATING
GLASS SUBSTRATE

) Group Art Unit: 2825

) Examiner: L. Malsawma

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)

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).


Applicant submits an English translation of JP 59-121876 which was initially submitted with the Information Disclosure Statement filed July 16, 2001.

A check in the amount of \$180 is being submitted to comply with the provisions of 37 C.F.R. § 1.97(c).

The Commissioner is hereby authorized to charge fees under 37 C.F.R. §§1.16, 1.17, 1.20(a), 1.20(b), 1.20(c), and 1.20(d) (except the Issue Fee) which may be required now or hereafter, or credit any overpayment to Deposit Account No. 50-2280.

A duplicate copy of this sheet is attached.

Respectfully submitted,



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PTO/SB/08A (08-00)

Approved for use through 10/31/2002. OMB 0651-0031

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Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Application Number	09/904,906
				Filing Date	July 16, 2001
				First Named Inventor	Takeshi FUKADA et al.
				Group Art Unit	2825
				Examiner Name	L. Malsawma
Sheet 1	1	of	1	Attorney Docket Number	0756-2332

U.S. PATENT DOCUMENTS						
Examiner Initials ¹	Cite No. ¹	U S Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (if known)			
		4,851,363		Troxell et al.	07/25/1989	
		4,876,582		Janning	10/24/1989	
		5,182,620		Shimada et al.	01/26/1993	
		5,374,570		Nasu et al.	12/20/1994	
		5,696,386		Yamazaki	12/09/1997	
		5,736,751		Mano et al.	04/07/1998	
		5,946,561		Yamazaki et al.	08/31/1999	

FOREIGN PATENT DOCUMENTS							
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Office ³	Number ⁴	Kind Code ⁵ (if known)			
		JP---	59-121876			07/14/1984	FULL

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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